

Search Notes	Application No.	Applicant(s)
	10/715,420	LEE, KYOUNG-JU
	Examiner	Art Unit
	Antonio A Caschera	2676

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Keyword Searched: 345/589, 596, 600, 603, 604 382/167, 299	1/26-28/05	AC
Searched NPL: IEEE and ACM Digital Libraries	1/28/05	AC
Searched Euro and Japanese Patent Websites	1/28/05	AC
Search help obtained from: Kee Tung & Matthew Luu	1/27/05	AC